

Notice of References Cited

Application/Control No.

10/590,291

Applicant(s)/Patent Under
Reexamination
TATSUMI ET AL.

Examiner

HENG M. CHAN

Art Unit

1793

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,587,109 A	05-1986	Lyaudet et al.	423/15
*	B	US-5,002,740 A	03-1991	Cheresnowsky et al.	423/56
	C	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N	WO 00/71248	11-2000	WO	Kuroda et al.	
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	S					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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